



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
Group Art Unit 1763

In re Patent Application of

Jui-Ping LI, et al.

Application No. 09/546,936

Docket No. 201056-0052

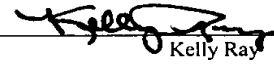
Filed: 11 April 2000

Examiner: MOORE, Karla A.

APPARATUS FOR FORMING FILM IN
SEMICONDUCTOR PROCESS AND METHOD
FOR FEEDING GAS INTO THE SAME
APPARATUS

I, Kelly Ray, hereby certify that this correspondence is being deposited with the US Postal Service as first class mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231, on the date of my signature.

RECEIVED
FEB 24 2003
TC 1700


Kelly Ray

10 Feb 03
Date

7B
2/28/03
mm

PRELIMINARY AMENDMENT

TO: Box RCE
Assistant Commissioner for Patents
Washington, DC 20231

- [X] AUTHORIZATION TO PAY AND PETITION FOR THE ACCEPTANCE OF ANY NECESSARY FEES: If any charges or fees must be paid in connection with the following Communication (including but not limited to the payment of issue fees), they may be paid out of our deposit account No. 50-1965. If this payment also requires a Petition, please construe this authorization to pay as the necessary Petition, which is required to accompany the payment.

In conjunction with the RCE mailed 10 February 2003 prior to examination, please amend the application as follows: